

Inventor Information

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|---------------------------|-----------|
| Inventor One Given Name:: | Akifumi |
| Family Name:: | KAMIJIMA |
| City of Residence:: | Tokyo |
| Country of Residence:: | Japan |
| Citizenship Country:: | Japan |
| Inventor Two Given Name:: | Hisayoshi |
| Family Name:: | WATANABE |
| City of Residence:: | Tokyo |
| Country of Residence:: | Japan |
| Citizenship Country:: | Japan |

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

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|------------------------|------------------------------------|
| Title Line One:: | A METHOD FOR FABRICATING A RESIST |
| Title Line Two:: | PATTERN, A METHOD FOR PATTERNING A |
| Title Line Three:: | THIN FILM AND A METHOD FOR |
| Title Line Four:: | MANUFACTURING A MICRO DEVICE |
| Total Drawing Sheets:: | 8 |
| Docket Number:: | 110735 |

Prior Foreign Applications

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|---------------------------|-----------------|
| Foreign Application One:: | 2000-305683 |
| Filing Date:: | October 5, 2000 |
| Country:: | Japan |
| Priority Claimed:: | Yes |

Assignee Information

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|-----------------------------|--------------------|
| Name of assignee:: | TDK Corporation |
| Assignee Address Line One:: | 1-13-1, Nihonbashi |
| Assignee Address Line Two:: | Chuo-ku |
| City:: | Tokyo |
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